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#5

Applicant:

Kie Y. Ahn et al.

Title:

SELECTIVE ELECTROLESS-PLATED COPPER METALLIZATION

Docket No.:

Examiner:

303.672US1

Serial No.: 09/483881

Filed:

January 18, 2000 Ha T. Nguyen Due Date: April 23, 2004 Group Art Unit: 2812

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

- $\underline{X}$  A return postcard.
- X An Amendment and Response (13 Pages).
- X A Petition for Extension of Time (1 pg.)
- X A check in the amount of \$110.00 to cover the Extension of Time Fee.
- X A Communication Concerning Related Applications (2 pgs.)
- X A Supplemental Information Disclosure Statement (2 pgs.), Form 1449 (1 pg.), and copies of 11 cited documents.
- $\underline{X}$  A check in the amount of \$180.00 to cover the fee for consideration of Information Disclosure Statement under 97(c).

If not provided for in a separate paper filed herewith, Please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

Customer Number 21186

Atty: Timothy B Clise Reg. No. 40,957

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SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

(GENERAL)

## IN THE COUTED STATES PATENT AND TRADEMARK OFFICE

Applicant: Kie Y. Ahn et al. Examiner: Ha T. Nguyen

Serial No.: 09/483881 Group Art Unit: 2812

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Title: SELECTIVE ELECTROLESS-PLATED COPPER METALLIZATION

## COMMUNICATION CONCERNING RELATED APPLICATION(S)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Applicants would like to bring to the Examiner's attention the following related application(s) in the above-identified patent application:

<u>Serial/Patent No.</u> 09/854540	Filing Date May 14, 2001	Attorney Docket 1303.013US1	Title COPPER DUAL DAMASCENE INTERCONNECT TECHNOLOGY
09/901001	July 9, 2001	1303.016US1	COPPER ELECTROLESS DEPOSITION TECHNOLOGY FOR ULSI METALIZATION
09/488098 6429120	January 18, 2000	303.618US1	METHOD AND APPARATUS FOR MAKING INTEGRATED-CIRCUIT WIRING FROM COPPER, SILVER, GOLD, AND OTHER METALS
09/484303	January 18, 2000	303.648US1	METHODS FOR MAKING INTEGRATED-CIRCUIT WIRING FROM COPPER, SILVER, GOLD, AND OTHER METALS
09/483869 6420262	January 18, 2000	303.664US1	STRUCTURES AND METHODS TO ENHANCE COPPER METALLIZATION
09/484002 6376370	January 18, 2000	303.673US1	PROCESS FOR PROVIDING SEED LAYERS FOR USING ALUMINUM, COPPER, GOLD AND SILVER METALLURGY

Serial Number: 09/483881

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Title: SELECTIVE ELECTROLESS-PLATED COPPER METALLIZATION

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10/117041	April 5, 2002	303.673US2	INTEGRATED CIRCUIT AND SEED LAYERS
10/196078	July 16, 2002	303.664US2	STRUCTURES AND METHODS TO ENHANCE COPPER METALLIZATION
10/196081	July 16, 2002	303.664US3	STRUCTURES AND METHODS TO ENHANCE COPPER METALLIZATION
10/211855	August 1, 2002	303.618US2	METHOD AND APPARATUS FOR MAKING INTEGRATED-CIRCUIT WIRING FROM COPPER, SILVER, GOLD, AND OTHER METALS
10/195965	July 16, 2002	303.664US4	STRUCTURES AND METHODS TO ENHANCE COPPER METALLIZATION
10/789882	February 27, 2004	303.673US3	INTEGRATED CIRCUIT AND SEED LAYERS

Respectfully submitted,

KIE Y. AHN ET AL.

By Applicants' Representatives,

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Name

Signature